

#17

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of)
Shunpei YAMAZAKI et al.) Group Art Unit: 2818
Serial No. 09/466,828) Examiner: R. Berry
Filed: December 20, 1999)
For: INSULATING FILM AND METHOD OF) Dated: May 10, 2002
PRODUCING SEMICONDUCTOR) Docket No: 740756-2077
DEVICE)

**PETITION FOR WITHDRAWAL FROM ISSUE
TO PERMIT CONSIDERATION OF INFORMATION
DISCLOSURE STATEMENT UNDER
SECTION 1.97 IN A CONTINUING APPLICATION**

Office of Petitions
Honorable Commissioner for Patents and Trademarks
Washington, D.C. 20231

RECEIVED
MAY 10 2002
OFFICE OF PETITIONS

Sir:

Applicants hereby petition for the withdrawal of this application from issue. The issue fee for this case was paid on February 28, 2002.

The reason for withdrawal from issue of this application is for consideration of Information Disclosure Statement in a continuing application. The continuing application is filed as a Request for Continued Examination Application (RCE). The RCE, which is entitled to priority under 35 U.S.C. 120 from this application, is being filed on the same date as this petition and accompanies this petition.

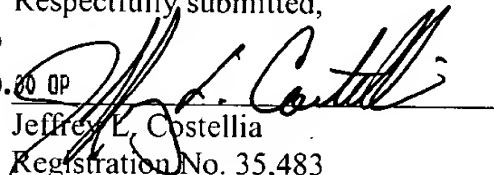
The petition fee of \$130 under 37 C.F.R. 1.17(i) is enclosed. The Commissioner is authorized to charge any deficiencies (except the issue fee) or credit any overpayment to Deposit Account No. 19-2380 (740756-2077). A duplicate copy of this sheet is attached.

Respectfully submitted,

05/14/2002 AKELLEY 00000017 09466828

02 FC:122

130.00 OP


Jeffrey L. Costellia
Registration No. 35,483

NIXON PEABODY LLP
8180 Greensboro Drive, Suite 800
McLean, Virginia 22102
(703) 790-9110
(703) 883-0370